N-111 NEXLINE® OEM Linear Actuator

Nanopositioning Over Long Travel, PiezoWalk® Principle



■ Travel Range 10 mm

N-111 compact

travel range

- Resolutionto 0.025 nm Open-Loop, 5 nm Closed-Loop
- Up To 50 N Force Generation and 70 N Holding Force
- Self Locking at Rest, No Heat Generation
- Non-Magnetic and Vacuum-Compatible Working Principle
- Cleanroom Compatible

The innovative N-111 NEX-LINE® OEM linear actuators are compact actuators for nanopositioning with travel ranges to 10 mm, high resolution, and generated forces to 50 N. The operating principle is based on coordinated motion of a number of highly preloaded linear and shear piezo elements acting on a runner. NEXLINE® drives thus combine long travel ranges with piezo-class pre-

Application Examples

- Semiconductor technology
- Semiconductor testing
- Wafer inspection
- Nano lithography
- Nano-imprinting
- Nanometrology
- Active vibration damping
- Motion in strong magnetic fields

cision. For closed-loop operation without an additional position sensor the N-111.2A is equipped with a linear encoder that provides 5 nm resolution over the full travel range. In open-loop operation position resolution down to 25 picometers can be achieved by use of a high-dynamics analog mode.

NEXLINE® Working Principle for Application Flexibility

NEXLINE® PiezoWalk® drives can be used wherever high loads must be positioned very precisely over long distances and then perhaps subjected to small-amplitude dynamic adjustment, as for active vibration control. By varying the combination of longitudinal and shear piezo elements, the step size, dynamic operating range (analog travel), clamping force, speed and stiffness can all be optimized for a particular application.

One Working Principle -**Different Operating Modes**

NEXLINE® PiezoWalk® drives overcome the limitations of conventional nanopositioning systems in their combination of long travel ranges and high resolution and stiffness. The piezoceramic clamping and shear elements act directly on a moving runner that is coupled to the moved object. While in full step mode the runner can be moved over larger distances with maximum velocity, nanostepping mode allows uniform motion with highly constant speed. In openloop operation any position resolution may be achieved which only depends on the stability of the control signal. Analog operation over a distance of less than one step enables high-dynamics positioning with resolutions far below one nanometer.

Choice of Controllers for Optimization

NEXLINE®operation is supported by two motion controller models providing different features. The E-755 controller offers full functionality for nanometer precise positioning. The E-712 supplies more sophisticated linearization

Ordering Information

N-111.20

NEXLINE® OEM Piezo Stepping Actuator, 10 mm, 50 N

NEXLINE® OEM Piezo Stepping Actuator, 10 mm, 50 N. Linear Encoder, 5 nm Resolution

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algorithms resulting in very smooth motion with highly constant velocity. It can also provide higher speed with maximum force.

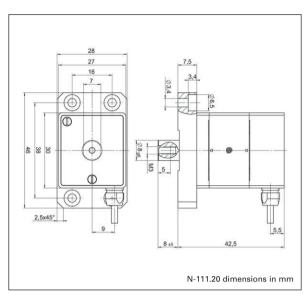
Patented Technology

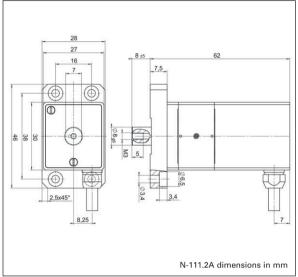
The products described in this document are in part protected by the following patents: German Patent No. 10148267 US Patent No. 6,800,984



Z / tip / tilt platform with NEXLINE® drives and position sensors; 300 mm (12") diameter, 200 N load capacity, 1.3 mm travel range, 10 mrad tilt range







Technical Data

| rechnical Data | | | |
|---|---|--|-----------|
| Model | N-111.20 | N-111.2A | Tolerance |
| Active axes | Х | Х | |
| Motion and positioning | | | |
| Travel range | 10 mm | 10 mm | |
| Step size (in step mode) | 10 nm to 7 μm | 10 nm to 7 μm | |
| Travel range in analog mode | ±2 μm | ±2 μm | |
| Integrated sensor | - | Linear encoder | |
| Open-loop resolution | 0.025 nm | 0.025 nm | typ. |
| Closed-loop resolution | - | 5 nm | |
| Max. velocity (10 % duty cycle, full step mode)* | 1.0 mm/s | 1.0 mm/s | |
| Max. velocity (100 % duty cycle, full step mode)* | 0.6 mm/s | 0.6 mm/s | |
| Max. velocity (100 % duty cycle, nanostepping mode)** | 0.4 mm/s | 0.4 mm/s | |
| Mechanical properties | | | |
| Stiffness in motion direction | 16 N/μm | 16 N/μm | ±20% |
| Drive force (active)*** | 50 N | 50 N | max. |
| Holding force (passive) | 70 N | 70 N | min. |
| Drive properties | | | |
| Motor type | NEXLINE® | NEXLINE® | |
| Operating voltage | ±250 V | ±250 V | |
| Miscellaneous | | | |
| Operating temperature range | -40 to 80 °C | -40 to 80 °C | |
| Material | Aluminium stainless steel, titanium | Aluminium stainless steel, titanium | |
| Mass | 245 g | 325 g | |
| Cable length | 1.5 m | 1.5 m | ±10 mm |
| Connector | Sub-D connector NEXLINE® single-channel | Sub-D connector NEXLINE® single-channel plus sensor connector | |
| Recommended controller | E-755,101, E-712 | E-755.1A1, E-712 | |

^{*} Depending on drive electronics. Data refer to operation together with E-712 controller.

Linear Actuators & Motors

PiezoWalk® Motors / Actuators

PILine® Ultrasonic Motors

DC-Servo & Stepper Actuators

Piezo Actuators & Components

Guided / Preloaded Actuators

Unpackaged Stack Actuators
Patches/Benders/Tubes/Shear...

Nanopositioning / Piezoelectrics

Nanometrology

Micropositioning

Index

^{**} Depending on drive electronics. Data refer to operation together with E-712 controller. Together with the E-755 controller a velocity of up to 0.1 mm/s (closed-loop) and 0.2 mm/s (open-loop) can be achieved. The maximum speed in nanostepping mode is set so as to ensure the highest possible velocity constancy, with no speed fluctuations while steps are being performed.

^{***} Data refer to full step mode operation.